

Date: March 31, 2006

Page 1 of 1

IP2002-098257
 PCT/EP2004/052383
 MAR 2006

| | | | | |
|--------------|--|--|------------------|-----------------|
| (REV. 05/03) | U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE | | ATTY. DOCKET NO. | APPLICATION NO. |
| | INFORMATION DISCLOSURE CITATION (Use several sheets if necessary) | | EISEN-004XX | 80/574204 |
| | APPLICANT: Volkmar Stenzel et al. | | | |
| | FILING DATE Herewith | | TC ART UNIT | |

U.S. PATENT DOCUMENTS

| EXAMINER INITIAL | DOCUMENT NUMBER | PUBLICATION/ ISSUE DATE | NAME | CLASS | SUBCLASS | FILING DATE |
|---------------------|------------------|----------------------------|--------------|-------|----------|-------------|
| /M.B./ | * US 2002/098257 | 07-2002 | Ikeda et al. | | | |
| | | | | | | |

FOREIGN PATENT DOCUMENTS

| | DOCUMENT NUMBER | DATE | COUNTRY | CLASS | SUBCLASS | TRANSLATION YES NO |
|--------|-------------------------|---------|--------------------|-------|----------|-----------------------|
| | * WO 00/30869 | 06-2000 | WIPO | | | |
| | * DE 102 03 250 | 07-2003 | Germany | | | |
| | * EP 1 003 078 | 05-2000 | European Pat. Off. | | | |
| | * EP 1 366 888 | 12-2003 | European Pat. Off. | | | |
| | * JP 02 202623 Abstract | 09-1991 | Japan | | | |
| | * DE 42 07 210 | 09-1993 | Germany | | | |
| /M.B./ | ** DE 196 13 383 | 08-1997 | Germany | | | |
| /M.B./ | ** EP 0 205 289 | 12-1986 | European Pat. Off. | | | |
| /M.B./ | ** DE 299 23 870 | 07-2001 | Germany | | | |
| /M.B./ | ** DE 101 08 469 | 09-2002 | Germany | | | |

OTHER DOCUMENTS (including Author, Title, Date, Pertinent Pages, etc.)

| | |
|--------|--|
| /M.B./ | ** Mehnert, Reiner; Sobotka, A.; Elsner, Ch.: "Microstructured Polyacrylate Surfaces Generated by UV&EB Curing," Proc. RadTech Europe 2001, (Exhibition & Conference for Radiation Curing, October 8-10, 2001, Basle, Switzerland), pp. 603-608. |
|--------|--|

| | | |
|----------|--------------------------------|-----------------|
| EXAMINER | /Margaret Brodie/ (02/24/2009) | DATE CONSIDERED |
|----------|--------------------------------|-----------------|

*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

CLG/mc/334412.1

* References furnished by International Bureau (PCT/EP2004/052383)

** References enclosed